

Testing strategy and timeline of E-det 80k

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Sensors - timeline



- Metallization started 1.05. → sensors available August 2016
- Wafer level testing
 - 1. Testing after Al1
 - 2. Testing after Al2
 - 3. Testing after Cu
- Dynamic testing assembled sensor structures
 - 1. Single DEPFETs, small DEPFET arrays
 - 2. Small test matrices
 - 3. Large quadrants

A1 level testing – wafer level after Al1

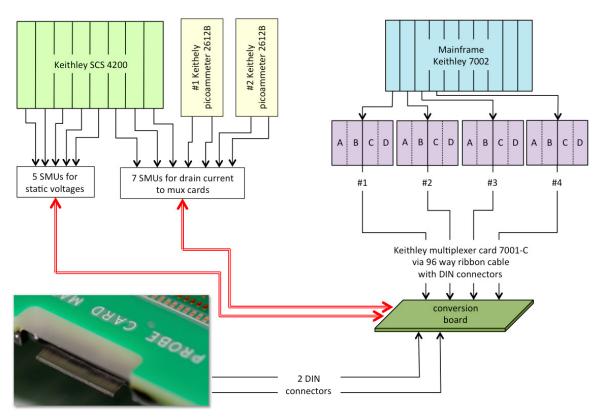


- Basic static measurements of DEPFETs and Diodes, CAPs quality of the production
- @ manual probe station in the clean room
- Planned end of May/June 2016
- No preparations necessary
- status: ready for execution as soon as wafers are at the stage

A2 level testing – wafer level after Al2



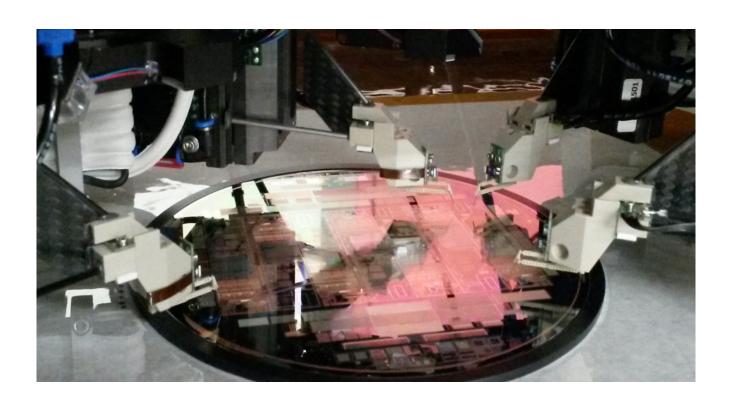
- Check of the integrity of the metal system in the sensor area: shorts and opens
- At semiautomatic probe station in the prober lab reuse the PXD switching system
- Planned end June 2016
- Probe card necessary small changes to be implemented compared to the BELLE one



A3 level testing – wafer level after Cu



- Check of the integrity of the metal system in the non-sensor area: shorts and opens
- At flying prober in the prober lab
- Planned end July/August 2016
- Hardware available

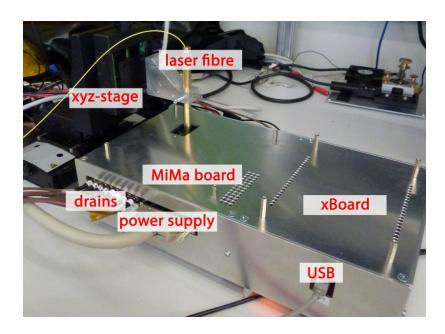


B1 level testing – single DEPFETs, small DEPFET arrays



- First dynamic measurements on DEPFETs non linearity measurement
- Single pixel setup is in preparation (Martin/Johannes) to be ready July 2016
- MIMA setup to be revived and operational @ HLL with help of Charles University Prague
- First structures assembled in August 2016
- After those measurements we can/should continue with remaining wafers
- Estimate: end Oct 2016 to start processing of remaining wafers

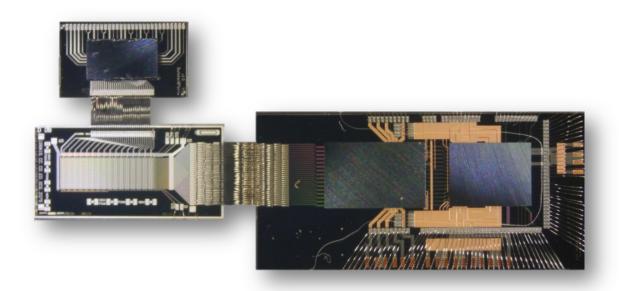




B2 level testing – small DEPFET matrices



- First structures assembled in August 2016
- Start with SW+DCDE+DHP testing on Hybrid 5
 - DMC will be compatible with existing Hybrid 5 layout so that once it is available it can be tested using this system – special wire-bond adapter needs to be produced (Oct-Nov 2016)
- Dedicate one PXD test setup with DHEv2 (2 x Infiniband connectors) and two Hybrid 5
 PCBs to EDET
- Re-use PXD test software (EPICS and CS-Studio, Python scripts) for test setup
 - changes for DCDE + DMC readout needed
- Estimated testing Oct/Nov new PhD student @ HLL



B3 level testing – large DEPFET matrices



- First structures assembled in Oct/Nov 2016
- Start with all SW+DCDE+DHP testing on thick sensors system development and debug
 - DMC will be compatible with existing DHP layout so that once it is available it can be tested using this system
- Required changes to PXD setup
 - Hybrid L shaped patch panel
 - Power supply
 - Cooling system

Module 0 assembly and testing



- first system test– May/Jun 2017
 - Thick matrix
 - DCDE, SW, DMC
 - Hybrid, Power supply, cooling
 - DAQ rack with sequencer card raw data streaming to hard disk, DHE and ONSEN not needed for experiment
 - → First quadrant: end 2017

Summary



- Pilot run finished by August 2016
- Dynamic measurement on small structures to confirm non linear response by Oct/Nov 2016
- Main production resume by Nov 2016
- First large matrix assembly by Nov 2016 system test with DHP
- DMC available Feb 2017
- Module 0 assembly by May/June 2017
- Quadrant assembly by end 2017

